



#1001
H. Nguyen
JCA

**REPLY UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 2851**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION OF

Confirmation No.: 7680

VAN DER LAAN *et al.*

Group Art Unit: 2851

Appln. No.: 09/943,088

Examiner: H. NGUYEN

Filed: August 31, 2001

Title: METHOD OF OPERATING A LITHOGRAPHIC APPARATUS, LITHOGRAPHIC APPARATUS, METHOD OF MANUFACTURING A DEVICE, AND A DEVICE MANUFACTURED THEREBY

August 12, 2003

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RESPONSE AFTER FINAL UNDER 37 C.F.R. § 1.116

Hon. Commissioner of Patents
Washington, D.C. 20231

Sir:

In response to the Office Action dated April 2, 2003, please amend the above-identified application as follows:

RECEIVED
AUG 15 2003
TECHNOLOGY CENTER ART UNIT 2800